

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/537,952	Confirmation No.	1520
Applicant	:	Joseph M. AMATO		
Filed	:	June 8, 2005		
TC/A.U.	:	2829		
Examiner	:	Tung X. Nguyen		
Docket No.	:	US02 0574 US		
Customer No.	:	65913		
Title:		RESISTOR STRUCTURES TO ELECTRICALLY MEASURE UNIDIRECTIONAL MISALIGNMENT OF STITCHED MASKS		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE & AMENDMENT AFTER NOTICE OF ALLOWANCE

Sir:

In response to the Notice of Allowance dated May 16, 2008, please consider the following. Examiner had noted defects in the Oath & Declaration. Applicant has included a replacement Oath & Declaration along with the Issue Fee Payment.

Amendments to the Specification there are no amendments this paper.

Amendments to the Claims there are no amendments in this paper.

Remarks/Arguments begin on page 2 of this paper. A replacement Oath & Declaration follows.